

Interface modification of hole transport layer in tin-based halide perovskite solar cells

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Note S1. The current density-voltage characteristics of PEDOT:PSS film as an active layer (ITO/SAM/PDEOT:PSS/Cu).

The HTL layer is approximately 40 nm thick and has an effective area of 0.05 cm². The control, MeO-2PACz, and Me-4PACz exhibited conductivities of 0.06967 S, 0.10784 S, and 0.12939 S, respectively. The calculated values were 0.55736×10^{-2} mS cm⁻¹, 0.86272×10^{-2} mS cm⁻¹, and 1.03512×10^{-2} mS cm⁻¹, respectively, using the equation.

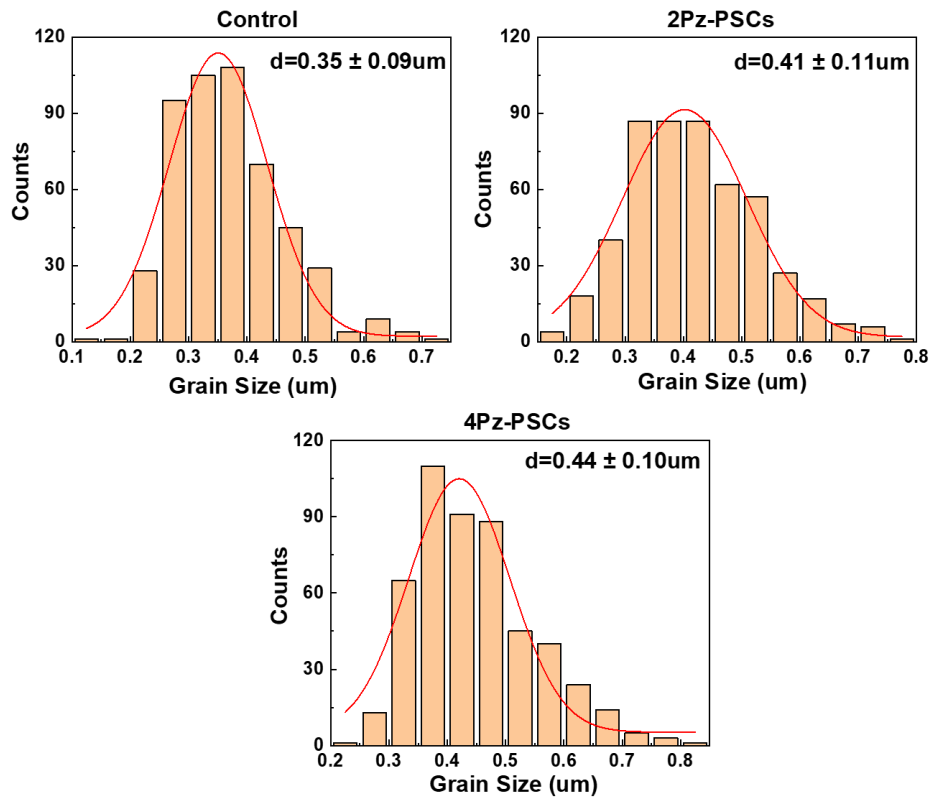


Figure S1. Size distribution histogram determined from top-view SEM image.

Table S1. The information of Sn XPS measurement deconvoluted into Sn²⁺ and Sn⁴⁺ peaks for control, 2Pz and 4Pz perovskite thin layers.

Sample	Ionic	Peak index	BE (ev)	FWHM (ev)	Percentage (%)	Relative ratio (Sn ⁴⁺ /Sn ²⁺) [%]
Control	Sn ²⁺	Sn 3d _{5/2}	486.00	1.17	32.66	45.0
		Sn 3d _{3/2}	494.41	1.17	32.87	
	Sn ⁴⁺	Sn 3d _{5/2}	486.77	1.16	17.22	
		Sn 3d _{3/2}	495.19	1.16	17.25	
2Pz/PVSK	Sn ²⁺	Sn 3d _{5/2}	486.06	1.18	34.59	44.1
		Sn 3d _{3/2}	494.48	1.18	34.82	
	Sn ⁴⁺	Sn 3d _{5/2}	486.81	0.98	15.25	
		Sn 3d _{3/2}	495.22	0.98	15.34	
4Pz/PVSK	Sn ²⁺	Sn 3d _{5/2}	486.07	1.19	37.70	32.2
		Sn 3d _{3/2}	494.48	1.19	37.92	
	Sn ⁴⁺	Sn 3d _{5/2}	486.84	0.98	12.15	
		Sn 3d _{3/2}	495.26	0.98	12.23	

Table S2. Fitted PL lifetimes of control and SAM-modified Sn-based perovskite films on glass substrates. A_1 and A_2 are fractional intensities, and τ_1 and τ_2 are lifetimes. The average carrier lifetime (τ_{ave}) was calculated with $\tau_{ave} = A_1*\tau_1+A_2*\tau_2$.

	$A_1(\%)$	τ_1 (ns)	$A_2(\%)$	τ_2 (ns)	τ_{ave} (ns)
Control	1.52	0.50	0.06	3.94	1.0
2Pz/PVSK	0.99	1.65	0.07	4.78	2.0
4Pz/PVSK	1.05	1.67	0.02	16.46	2.1

Figure S2. Champion device optical current density-voltage forward and reverse sweep curves.

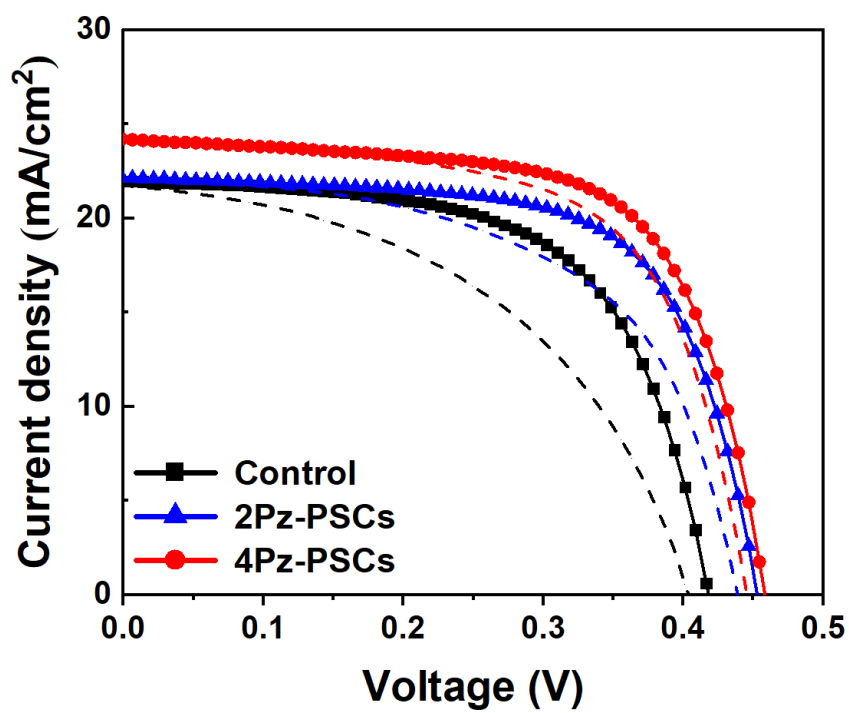


Table S3. Data were obtained from the EIS fitting circuit.

$$\tau = RC$$

Sample	R_{rec} (Ω)	C (F)	τ (μs)
Control	11747	7.238E^{-9}	85.018
2Pz-PSCs	16975	6.612E^{-9}	112.243
4Pz-PSCs	18483	7.292E^{-9}	134.778

Figure S3. DLTS spectra of (a) control devices, (b) 2Pz-PSCs, and (c) 4Pz-PSCs.

